



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

NAGAHAMA et al

Atty. Ref.: 925-179; Confirmation No. 2385

Appl. No. 09/500,288

Group: 2814

Filed: February 8, 2000

Examiner: Louie

For: NITRIDE SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD

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November 6, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

Responsive to the Official Action dated August 12, 2003, please amend the  
above-identified application as follows:

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